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CONFIRMATION NO. 8933

<b>SERIAL NUMBER</b> 10/506,534	<b>FILING OR 371(c) DATE</b> 09/03/2004 <b>RULE</b>	<b>CLASS</b> 438	<b>GROUP ART UNIT</b> 2812	<b>ATTORNEY DOCKET NO.</b> 061063-0311751	
<b>APPLICANTS</b> Takashi Shibayama, Kishima-gun, JAPAN; Yoshio Murakami, Saitama-shi, JAPAN; Takayuki Shingyoji, Saitama-shi, JAPAN;					
<b>***** FILING DATA *****</b> This application is a 371 of PCT/JP03/02568 03/05/2003					
<b>***** FOREIGN APPLICATIONS *****</b> JAPAN 2002-261286 09/06/2002 JAPAN 2002-059182 03/05/2002					
Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 (a-d) conditions <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Verified and Acknowledged <i>Allowance</i> Examiner's Signature <i>5/11</i> Initials		<b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWING</b> 8	<b>TOTAL CLAIMS</b> 5	<b>INDEPENDENT CLAIMS</b> 1
<b>ADDRESS</b> 00909					
<b>TITLE</b> Process for producing silicon single crystal layer and silicon single crystal layer					
<b>FILING FEE RECEIVED</b> 920	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees ( Filing ) <input type="checkbox"/> 1.17 Fees ( Processing Ext. of time ) <input type="checkbox"/> 1.18 Fees ( Issue ) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		